

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: ) Previous Examiner: P. Connolly  
Osamu KAKUCHI et al. )  
Application No.: Divisional of Application )  
No. 09/533,376, filed March 22, 2000 )  
Filed: July 17, 2003 ) July 17, 2003  
For: EXPOSURE APPARATUS WITH )  
INTERFEROMETER )

**Mail Stop Patent Application**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT AND  
LETTER SUBMITTING SUBSTITUTE SPECIFICATION

Sir:

Prior to examination on the merits, please amend the above-identified application as follows:

INTRODUCTORY COMMENTS

This Amendment has been prepared in accordance with the Revised Format established by the U.S. Patent and Trademark Office, as permitted in the Pre-OG Notice dated February 4, 2003, and entitled "Amendments in a Revised Format Now Permitted."